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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/763,353	01/23/2004	Randy Hoffman	200311332-2	7102
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HEWLETT P	ACKARD COMPANY	7	MONDT, JO	HANNES P
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INTELLECTUAL PROPERTY ADMINISTRATION			ART UNIT	PAPER NUMBER
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DATE MAILED: 10/05/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/763,353	HOFFMAN ET AL.				
Office Action Summary	Examiner	Art Unit				
	Johannes P. Mondt	2826				
The MAILING DATE of this communication apperiod for Reply	pears on the cover sheet with th	e correspondence address	•			
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D - Extensions of time may be available under the provisions of 37 CFR 1.4 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailine earned patent term adjustment. See 37 CFR 1.704(b).	NATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be will apply and will expire SIX (6) MONTHS for cause the application to become ABANDO	ON. timely filed om the mailing date of this communical NED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on						
· · · · · · · · · · · · · · · · · · ·	s action is non-final.					
3) Since this application is in condition for allowa	ince except for formal matters,	prosecution as to the merits	is			
closed in accordance with the practice under	Ex parte Quayle, 1935 C.D. 11,	453 O.G. 213.				
Disposition of Claims						
4)⊠ Claim(s) <u>1-49</u> is/are pending in the application	1.					
4a) Of the above claim(s) 44 is/are withdrawn						
5) Claim(s) is/are allowed.						
6) Claim(s) 1-3, 5-18, 20-28, 30-37, 40-43, 45-47	7 and 49 is/are rejected.					
7) Claim(s) 4,19,29,38,39 and 48 is/are objected	_					
8) Claim(s) are subject to restriction and/o	or election requirement.					
Application Papers						
9) The specification is objected to by the Examine	er .					
10) The drawing(s) filed on is/are: a) acc		e Examiner.				
Applicant may not request that any objection to the						
Replacement drawing sheet(s) including the correc	• , ,	` '	1(d).			
11) The oath or declaration is objected to by the Ex						
Priority under 35 U.S.C. § 119						
12)☐ Acknowledgment is made of a claim for foreign a)☐ All b)☐ Some * c)☐ None of:		(a)-(d) or (f).				
1. Certified copies of the priority document						
2. Certified copies of the priority document	• • • • • • • • • • • • • • • • • • • •					
3. Copies of the certified copies of the prior	•	ived in this National Stage				
application from the International Burea		und				
* See the attached detailed Office action for a list	of the certified copies not rece	vea.				
AML						
Attachment(s) 1) X Notice of References Cited (PTO-892)	4) Interview Summa	ary (PTO-413)				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail	Date				
3) 区 Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date <u>1/23/4,7/14/4,12/1</u> 3/4 (3 から。)	5) Notice of Informa 6) Other:	l Patent Application (PTO-152)				

DETAILED ACTION

Election/Restrictions

Applicant's election without traverse of the Group I invention (claims 1-43 and 45-49) in the reply filed on 8/2/2005 is acknowledged.

Information Disclosure Statement

The examiner has considered the items listed in the Information Disclosure Statements filed 1/23/04, 7/14/04 and 12/13/04. A signed copy of Form PTO-1449 is herewith enclosed.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

 Claims 14 and 15 recite the limitation "the dielectric material" in lines 1 of claims 14 and 15. There is insufficient antecedent basis for this limitation in the claim.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
 - Claims 1-2, 7-12, 16, 17, 22-27 and 32-37 are rejected under 35
 U.S.C. 102(b) as being anticipated by Cillessen et al (5,744,864) (made of record by Applicant in IDS).

Cillessen et al teach (title, abstract, Figures 2 and 4, cols. 4-10) a semiconductor device (title), comprising: a source electrode and drain electrode (2 and 3 or vice versa: source and drain only non-interchangeable after a purely arbitrary selection of the sign of the voltage difference applied between said source and drain electrode, considering the symmetry of the device; cf. Figures 2 and 4 and abstract), a channel 4 (abstract) coupled to the source and drain electrodes and comprised of a ternary compound containing zinc, tin and oxygen (col. 5, I. 30-50); and a gate electrode 5 (abstract) configured to permit application of an electric field to the channel (that is the very purpose of any gate electrode in the semiconductor device art).

On claim 2: at least a portion of the channel is formed from a zinc-tin oxide compound (col. 5, I. 41), while inherently any zinc-tin oxide compound obtained by forming a compound from ZnO and SnO2 only has the stoichiometry Zn_xSn_yO_z with positive non-zero values.

On claims 7-10 and 35: one or more (in fact all) of the source, drain and gate electrodes is fabricated so as to be at least partially transparent (see abstract).

On claims 8-9 and 33-34: the channel further includes, based on the presence of the claimed ZnSnO₃ compound, phase-segregated ZnO and SnO₂ by virtue of the finite dissociation constant of ZnSnO₃.

On claims 11 and 36: the further limitation of claims 11 fail to further limitation the semiconductor device as elected, but instead merely further limits the method of making of said semiconductor device.

On claims 12 and 37: the source and drain electrodes, casu quo, first and second electrodes are formed of indium-tin-oxide (see col. 2, I. 31-41 in conjunction with col. 5, I. 51-60) and are physically separate from one another (Figures 2 and 4), which also is inherent in source and drain electrodes in a functional semiconductor device with channel between source and drain electrode as otherwise said channel could not function because of short-circuiting. The limitation on patterning also included in these claims fails to limit the invention of the semiconductor device casu quo thin film transistor but instead only limits their method of making.

On claim 13: the gate electrode is physically separated from the channel by a dielectric material 6 (abstract).

On claims 16-17: Cillessen et al teach (title, abstract, Figures 2 and 4, and cols. 4-10) a three-port semiconductor device comprising: a source electrode (2 or 3), a drain electrode (3 or 2) (see abstract), a gate electrode 5 (abstract), and means for providing a channel 4 (abstract) disposed between the source electrode and the drain electrode configured to permit movement of electric charges therethrough between the source and the drain electrode, the means for providing a channel formed at least in part from a ternary compound containing zinc, tin and oxygen (col. 5, I. 30-50), said means including a zinc-tin oxide compound (loc.cit.), while inherently any zinc-tin oxide compound obtained by forming a compound from ZnO and SnO2 only has the stoichiometry Zn_xSn_yO_z with positive non-zero values (claim 17).

On claims 22 and 32: one or more (in fact all) of the source, drain and gate electrodes is fabricated so as to be at least partially transparent (see abstract).

On claim 23: the source and drain electrodes are formed of indium-tin-oxide (see col. 2, I. 31-41 in conjunction with col. 5, I. 51-60) and are physically separate from one another (Figures 2 and 4), which also is inherent in source and drain electrodes in a functioning semiconductor device with channel between source and drain electrode as otherwise said channel could not function because of short-circuiting. The further limitation on patterning fails to limit the semiconductor device but instead only limits its method of making.

On claim 24:the semiconductor device further comprises means 6 (see abstract) for providing a dielectric disposed between and physically separating the gate electrode 5 (abstract) from the means 4 (abstract) for providing a channel.

On claim 25: Cillesen et al teach (cols. 4-10, Figures 2 and 4, title and abstract) a thin film transistor (col. 1, I. 5-18: the device of JP 60-198861 is a thin film transistor), comprising: a gate electrode 5 (abstract); a channel layer 4 (abstract) formed from a zinc-tin oxide material (col. 5, I. 30-50); a dielectric material 6 (abstract) disposed between and separating the gate electrode and the channel layer (Figures 2 and 4); and first and second electrodes 2 and 3 (abstract) spaced from each other and disposed adjacent the channel layer on a side of the channel opposite the dielectric material (Figures 2 and 4) such that the channel layer is disposed between and electrically separates the first and second electrodes (Figures 2 and 4). N.B.: the latter limitation also is merely a defining property of theb thin film transistor.

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On claim 26: the thin film transistor is by definition of a thin film transistor configured to the limitation of this claim, because a thin film transistor is a field effect transistor.

On claim 27: at least a portion of the channel is formed from a zinc-tin oxide compound (col. 5, I. 41), while inherently any zinc-tin oxide compound obtained by forming a compound from ZnO and SnO₂ only has the stoichiometry $Zn_xSn_yO_z$ with positive non-zero values.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
 - Claims 3, 5, 6, 18, 20, 21, 28, 30 and 31 are rejected under 35 U.S.C.
 103(a) as being unpatentable over Cillessen et al (5,744,864) in view of Minami et al (Japanese Journal of Applied Physics, Vol. 23, pp. L 1693-1696 (1994), made of record by Applicant by IDS).

As detailed above, Cillessen et al anticipate claim 2. Cillessen et al do not necessarily teach the further limitation defined by claims 3, 5, 6 or 18. However, it would have been obvious to include said further limitations in view of Minami et al, who teach high (electrical) conductivity for a particular amorphous (see page L1694, first column, first paragraph; claims 6, 21 and 31) zinc-tin oxide compound, namely: ZnSnO₃ (see abstract) (claims 3, 18 and 28). Because electrical conductivity and mobility are

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proportional they also report high mobility. Applicant is reminded that mere selection of known materials generally understood to be suitable to make a device, the selection of the particular material being on the basis of suitability for the intended use, would be entirely obvious. In re Leshin 125 USPQ 416.

With regard to claims 5, 20 and 30: it is noted that for $j=\frac{1}{2}$ the compound $(ZnO)_{j}(SnO2)_{1-j}$ is identical to $ZnSnO_3$, only the relative amounts, i.e., the ratios, being physical.

3. Claims 40-43, 45 and 46 are rejected under 35 U.S.C. 103(a) as being unpatentable over Cillessen et al (5,744,864) in view of Ando et al (6,184,946 B1).

As detailed above, Cillessen et al teach a three-port semiconductor device (Figures 2 and 4, cols. 4-10, title and abstract), where the semiconductor device 1 includes a zinc-tin oxide channel layer 4 configured to permit charge transport between a source electrode (2 or 3) and a drain electrode (3 or 2) of the semiconductor device based upon a gate voltage applied to the gate electrode 5 of the semiconductor device., with reference to the abstract and Figures 2 and 4 for numerals. Cillessen et al do not necessarily teach the claimed method of controlling an active matrix display comprising said three-port semiconductor device and also comprising selectively controlling activation an deactivation of a pixel of the active matrix display by selectively controlling the gate voltage; however, such is an obvious application of said three-port device, because said three-port device is a thin film transistor (col. 1 and particularly the reference to Japanese document 60-198861, which discloses a thin film transistor) in

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view of Ando et al, who teach the application of thin film transistors (TFTs) (col. 4, I. 3-25), in particular as switching elements (abstract) used for switching in a method for controlling an active matrix display (title, abstract), wherein the TFT selectively controls activation and deactivation of a pixel of the active matrix display by selectively controlling the gate voltage (cols. 1-col. 2, I. 5: that is how thin film transistor function). Motivation to include the teaching by Ando et al in the invention by Cillessen et al derives from the obvious advantage of applying a transparent and high mobility TFT such as taught by Cillessen et al to said active matrix display because little light is lost by absorption by the thin film transistor while the device speed is still high. With regard to claim 43, the limitations delineated above are all met because TFT 18 is a switching thin film transistor of the enhancement mode type (normally OFF) (see col. 2, I. 7-13 and abstract), which means that a positive gate voltage creates a conductive channel (see, for instance, Wolf, ISBN: 0-961672-5-3; page 136-137). The further limitations of <u>claims 41-42</u> are also met because the pixel electrode is connected to the drain electrode. With regard to claim 45 its limitations are automatically met given the above discussion because said active matrix display in the combined invention by Cillessen et al and Ando et al comprises a plurality of display elements configured to operate collectively to display images (see "Background Art" in Ando et al), where each of the display elements (as elements of a matrix) includes a semiconductor device (TFT) to control light emitted by the display element, the semiconductor device including: a source electrode, a drain electrode (2 and 3, resp. in Cillessen et al) a channel 4 coupled to the source electrode and drain electrode and comprised of a ternary

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compound containing zinc, tin and oxygen (col. 5, I. 30-50 in Cillessen et al); and a gate electrode 5 configured to permit application of an electric field to the channel.

On claim 46: at least a portion of the channel is formed from a zinc-tin oxide compound (col. 5, I. 41), while inherently any zinc-tin oxide compound obtained by forming a compound from ZnO and SnO2 only has the stoichiometry Zn_xSn_yO_z with positive non-zero values.

4. Claims 47 and 49 are rejected under 35 U.S.C. 103(a) as being unpatentable over Cillessen et al and Ando et al as applied to claim 46 above, and further in view of Minami et al (Japanese Journal of Applied Physics, Vol. 23, pp. L 1693-1696 (1994), made of record by Applicant by IDS).

As detailed above claim 46 is unpatentable over Cillessen et al in view of Ando et al.

Neither Cillessen et al nor Ando et al necessarily teach the further limitation as defined by claims 47 and 49. However, it would have been obvious to include said further limitations in view of Minami et al, who teach high (electrical) conductivity especially for the zinc-tin oxide compound ZnSnO₃ (see abstract). Because electrical conductivity and mobility are proportional they also automatically report high mobility. Applicant is reminded that mere selection of known materials generally understood to be suitable to make a device, the selection of the particular material being on the basis of suitability for the intended use, would be entirely obvious. In re Leshin 125 USPQ 416.

With regard to <u>claim 49</u>: it is noted that for $j = \frac{1}{2}$ the compound $(ZnO)_j(SnO2)_{1-j}$ is identical to $ZnSnO_3$, only the relative amounts, i.e., the ratios, being physical.

Allowable Subject Matter

5. Claims 4, 19, 29, 38, 39 and 48 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

The following is a statement of reasons for the indication of allowable subject matter:

With regard to claims 4, 19, 29 and 48, the zinc-tin compound Zn₂SnO4 has not been found within the strict context of prior art defined by the underlying independent claims. Its manufacture is known (Minami et al as cited), but the incorporation into a TFT channel has not been found nor would it have been obvious to do so because of its considerably lower electric conductivity (see Minami et al, page L1693). Also noted is the study by Young et al as made of record in the IDS; however, only future directions of research to improve the relatively low electrical conductivity and mobility of Zn2SnO4 are indicated. No other prior art has been found.

With regard to claims 38 and 39, the particular material embodiment defined by these claims has not been found in the prior art within the strict context of the thin film transistor as defined by claim 25.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Johannes P. Mondt whose telephone number is 571-272-1919. The examiner can normally be reached on 8:00 - 18:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan J. Flynn can be reached on 571-272-1915. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

JPM October 1, 2005

Patent Examiner:

Johannes Mondt (Art Unit: 2826).